

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

David Abraham et al.

Serial No.: 10/680,260



Group Art Unit: 2814

Filed: October 8, 2003

Examiner: Mai, Anh D.

For: METHOD AND SYSTEM FOR PATTERNING OF MAGNETIC THIN FILMS USING
CHEMICAL TRANSFORMATION

Honorable Commissioner of Patents
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action dated April 10, 2006, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper. No new matter has been added.

Remarks begin on page 6 of this paper.